	Application No.	Applicant(s)
Notice of Allowability	09/901,038	YAMASHITA ET AL.
	Examiner	Art Unit
	Michelle Crowell	1763
The MAILING DATE of this communication appeal All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIP of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in or other appropriate communication. This application is	n this application. If not included unication will be mailed in due course. THIS
1. This communication is responsive to <i>April 26, 2006</i> .		
2. The allowed claim(s) is/are <u>1-8</u> .		•
 3. Acknowledgment is made of a claim for foreign priority ur a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 	e been received.	
3. Copies of the certified copies of the priority do		
International Bureau (PCT Rule 17.2(a)).	cuments have been receive	in this national stage application from the
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	ENT of this application.	
 A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give 		
5. 🔲 CORRECTED DRAWINGS (as "replacement sheets") mus	st be submitted.	
(a) ☐ including changes required by the Notice of Draftspers	son's Patent Drawing Revie	w (PTO-948) attached
1) hereto or 2) to Paper No./Mail Date		
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment o	r in the Office action of
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t		
 DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT 		
Attachment(s) 1. Notice of References Cited (PTO-892)	5. Notice of I	nformal Patent Application (PTO-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. Interview S	Summary (PTO-413),
3. Information Disclosure Statements (PTO-1449 or PTO/SB/0		/Mail Date s Amendment/Comment
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. 🛭 Examiner's	Statement of Reasons for Allowance
	9.	<u>_</u> .

DETAILED ACTION

EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Mr. Steven Becker on July 11, 2006.

2. The application has been amended as follows:

In the title

The title has been amended to "Plasma Processing System In Which A Wafer Is Retained By An Electrostatic Chuck"

In the specification

On page 6, line 21, deleted "prove", inserted –probe--.

In the claims

Claims 9-18 are cancelled.

REASONS FOR ALLOWANCE

3. The following is an examiner's statement of reasons for allowance:

The prior art, either singly or in combinations, fails to anticipate or render obvious a plasma processing system comprising: a processing chamber, a pair of electrodes, a RF feeding apparatus, a retaining/removal apparatus, and a detection apparatus for detecting the electrostatic-chucking state of the substrate and for detecting-removal state of electrical charges from the substrate, on the basis of variations in impedance arising between the sample table and the substrate.

With regard to the remand from the Board of Appeals (04-26-06), the Examiner agrees with the Board of Appeals that 112 6th paragraph is invoked. In Figure 1 (detection apparatus 11), page 6, lines 19-3, and page 7, lines 21-32 of the specification, the function of the detection apparatus is disclosed. Therefore, this functional limitation is given patentable weight and thus overcomes the prior art of record.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Michelle Crowell whose telephone number is (571) 272-1432. The examiner can normally be reached on M-F (9:30 -6:00).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Parviz Hassanzadeh can be reached on (571) 272-1435. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Michelle Crowell
Patent Examiner
Art Unit 1763

Parviz Hassanzadeh Supervisory Patent Examiner Art Unit 1763

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